M.E. MECHANICAL ENGINEERING FIRST YEAR SECOND SEMESTER 2023

ADVANCED METHODS OF MACHINING

Time: Three hours

Full Marks: (5 X 20=100)

Answer any five (5) questions.

Assume relevant data, if necessary.

- 1. a) In brief explain the process of CHM. Give a schematic schedule in PCM process.
- b) During AJM, the mixing ratio used is 0.2. Calculate mass ratio if the ratio of density of abrasive and density of carrier gas is equal to 20.
- c) Diameter of the nozzle is 1.0 mm and jet velocity is 200 m/s. Find the volumetric flow rate (cm³/s) of the carrier gas and abrasive mixture, V_{a+g}. [8+6+6]
- 2. a) Discuss the model proposed by M.C. Shaw in connection with work MRR and also derive an expression for the same in USM.
 - b). Show the variation of MRR with feeding force, frequency and amplitude in USM.

[14+6]

- 3. a). Discuss the tool design for ECM process.
 - b). EDM is used to machine a metallic sheet. Calculate surface finish value if $C=15\mu m$ $V_b = 130 \text{ V}$, $K_6 = 4.0$. Use the equation based on experimental results. [14+6]
- 4. a). Write the differences (in table form) between WJM, AJM, AFM, and AWJM processes (working principles, applications, limitations, and merits of the processes).
 - b). Explain the mechanics of EDM process and also the inaccuracies introduced during EDM operation.

[10+10]

- 5. a) With the help of a neat sketch explain the LAM process.
 - b) Discuss about high speed machining and hard machining.
 - c) Explain deformation machining.

[5+10+5]

[2]

- 6. a). Explain with neat sketch IBM process. Discuss about electrode characteristics, discharge mechanism, cathode emission and cathode sputtering.
 - b). Write the different advantages and disadvantages of IBM process

[15+5]

- 7.a). Discuss about the use of catcher and its types in AWJM. Also discuss about environmental issues relevant to AWJM.
 - b). Discuss about selective dissolution in ECM.

[10+10]

8. Write the short notes on any four of the following.

[5x4=20]

- a) Ductile regime machining.
- b) Peel grinding
- c) WEDM
- d) Surface finish using EDM
- e) Working principle of LBM
- f) Sporadic breakdown of anodic file in ECM

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